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(54) **SMALL GAP DEVICE SYSTEM AND  
METHOD OF FABRICATION**

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**ABSTRACT**

A small-gap device system, preferably including two or  
more electrodes and one or more spacers maintaining a gap  
between two or more of the electrodes. A spacer for a  
small-gap device system, preferably including a plurality of  
legs defining a mesh structure. A method of spacer and/or  
small-gap device fabrication, preferably including: defining  
lateral features, depositing spacer material, selectively  
removing spacer material, separating the spacer from a  
fabrication substrate, and/or assembling the small-gap  
device.

